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Notice of Allowability	Application No.	Applicant(s)	-10
	09/806,177	SCHMID, RAINER	
	Examiner	Art Unit	
	Helen C. Kwok	2856	
The MAILING DATE of this communication appears on the cover sheet with the correspondence address All claims being allowable, PROSECUTION ON THE MERITS IS (OR REMAINS) CLOSED in this application. If not included herewith (or previously mailed), a Notice of Allowance (PTOL-85) or other appropriate communication will be mailed in due course. THIS NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RIGHTS. This application is subject to withdrawal from issue at the initiative of the Office or upon petition by the applicant. See 37 CFR 1.313 and MPEP 1308.			
1. X This communication is responsive to 10/30/03.			
2. ⊠ The allowed claim(s) is/are <u>1-21</u> .			
3. The drawings filed on are accepted by the Examiner.			
 4. ☐ Acknowledgment is made of a claim for foreign priority ι a) ☐ All b) ☐ Some* c) ☐ None of the: 	under 35 U.S.C. § 119(a)-(d)	or (f).	
⊠ Certified copies of the priority documents have	e been received.		
2. Certified copies of the priority documents have been received in Application No			
3. Copies of the certified copies of the priority documents have been received in this national stage application from the			
International Bureau (PCT Rule 17.2(a)).			
* Certified copies not received:			
5. Acknowledgment is made of a claim for domestic priority reference was included in the first sentence of the specific	cation or in an Application Da	ata Sheet. 37 CFR 1:78.	;
(a) The translation of the foreign language provisional application has been received.			
6. Acknowledgment is made of a claim for domestic priority under 35 U.S.C. §§ 120 and/or 121 since a specific reference was included in the first sentence of the specification or in an Application Data Sheet. 37 CFR 1.78.			
Applicant has THREE MONTHS FROM THE "MAILING DATE" of this communication to file a reply complying with the requirements noted below. Failure to timely comply will result in ABANDONMENT of this application. THIS THREE-MONTH PERIOD IS NOT EXTENDABLE.			
7. A SUBSTITUTE OATH OR DECLARATION must be submitted. Note the attached EXAMINER'S AMENDMENT or NOTICE OF INFORMAL PATENT APPLICATION (PTO-152) which gives reason(s) why the oath or declaration is deficient.			
8. X CORRECTED DRAWINGS (as "replacement sheets") must be submitted.			
(a) ☐ including changes required by the Notice of Draftsperson's Patent Drawing Review (PTO-948) attached			
1) hereto or 2) to Paper No			
(b) ☐ including changes required by the proposed drawing Examiner.	correction filed 30 October	2003, which has been approved by the	
(c) ☐ including changes required by the attached Examiner's Amendment / Comment or in the Office action of Paper No			
Identifying indicia such as the application number (see 37 CFR 1.84(c)) should be written on the drawings in the front (not the back) of each sheet. Replacement sheet(s) should be labeled as such in the margin according to 37 CFR 1.121(d).			
9. DEPOSIT OF and/or INFORMATION about the department attached Examiner's comment regarding REQUIREMENT FOR			
Attachment(s)			
1☐ Notice of References Cited (PTO-892)	5∏ Notice of In	formal Patent Application (PTO-152)	
2 Notice of Draftperson's Patent Drawing Review (PTO-948)		ımmary (PTO-413), Paper No	
3⊠ Information Disclosure Statements (PTO-1449 or PTO/SB/ Paper No. 3/27/01	⁰⁸), 7⊠ Examiner's	Amendment/Comment	
4 Examiner's Comment Regarding Requirement for Deposit of Biological Material	8⊠ Examiner's 9⊡ Other	Statement of Reasons for Allowance	

Art Unit: 2856

DETAILED ACTION

EXAMINER'S AMENDMENT

1. An examiner's amendment to the record appears below. Should the changes and/or additions be unacceptable to applicant, an amendment may be filed as provided by 37 CFR 1.312. To ensure consideration of such an amendment, it MUST be submitted no later than the payment of the issue fee.

The application has been amended as follows:

On page 6, line 5, delete the phrase "Fig. 2" and replace with – Figs. 2A – 2C --.

2. The following is an examiner's statement of reasons for allowance:

The prior art of record does not suggest or teach a micromechanical rotation rate sensor comprising a substrate wafer arrangement; a structural wafer arrangement defined having a at least one seismic mass, suspension, at least one spring; an insulating organic connecting layer connecting the substrate wafer arrangement to the structural wafer arrangement.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

Conclusion

3. Any inquiry concerning this communication or earlier communications from the examiner should be directed to Helen C. Kwok whose telephone number is (703) 308-8149. The examiner can normally be reached on 8:30 to 5:00.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Hezron E. Williams can be reached on (703) 305-4705. The fax phone number for the organization where this application or proceeding is assigned is (703) 872-9306.

Any inquiry of a general nature or relating to the status of this application or proceeding should be directed to the receptionist whose telephone number is (703) 305-4900.

Helen C. Kwok

hck January 21, 2004